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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
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10/709,204

04/21/2004

Richard S. Wise

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06/12/2006

INTERNATIONAL BUSINESS MACHINES CORPORATION

DEPT. 18G

BLDG. 300-482

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HOPEWELL JUNCTION, NY 12533

EXAMINER

MALDONADO, JULIO J

ART UNIT

PAPER NUMBER

2823

DATE MAILED: 06/12/2006

Please find below and/or attached an Office communication concerning this application or proceeding.

## Office Action Summary

Application No.

10/709,204

Applicant(s)

WISE ET AL.

Examiner

Julio J. Maldonado

Art Unit

2823

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

### Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

### Status

- 1) ☒ Responsive to communication(s) filed on 10 April 2006.
- 2a) ☐ This action is **FINAL**. 2b) ☒ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

### Disposition of Claims

- 4) ☒ Claim(s) 8 and 10-12 is/are pending in the application.
- 4a) Of the above claim(s) \_\_\_\_\_ is/are withdrawn from consideration.
- 5) ☐ Claim(s) \_\_\_\_\_ is/are allowed.
- 6) ☒ Claim(s) 8 and 10-12 is/are rejected.
- 7) ☐ Claim(s) \_\_\_\_\_ is/are objected to.
- 8) ☐ Claim(s) \_\_\_\_\_ are subject to restriction and/or election requirement.

### Application Papers

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☐ The drawing(s) filed on \_\_\_\_\_ is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.  
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).  
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) ☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

### Priority under 35 U.S.C. § 119

- 12) ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
- a) ☐ All b) ☐ Some \* c) ☐ None of:
- ☐ Certified copies of the priority documents have been received.
  - ☐ Certified copies of the priority documents have been received in Application No. \_\_\_\_\_.
  - ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

\* See the attached detailed Office action for a list of the certified copies not received.

### Attachment(s)

- ☒ Notice of References Cited (PTO-892)
- ☐ Notice of Draftsperson's Patent Drawing Review (PTO-948)
- ☒ Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)  
Paper No(s)/Mail Date FIS920030028us1.
- ☐ Interview Summary (PTO-413)  
Paper No(s)/Mail Date. \_\_\_\_\_.
- ☐ Notice of Informal Patent Application (PTO-152)
- ☐ Other: \_\_\_\_\_.

## **DETAILED ACTION**

### ***Claim Rejections - 35 USC § 103***

1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

2. Claims 8 and 10-12 are rejected under 35 U.S.C. 103(a) as being unpatentable over Lee (U.S. 6,228,763 B1) in view of Zhao (U.S. 6,211,561 B1) and Chiang et al. (U.S. 5,817,572).

Lee (Figs.3A-3D) teaches an wiring structure including a first dielectric layer (300); a plurality of conductors (312) disposed on said first dielectric layer (300), said conductors (312) separated laterally from each other by portions of a second dielectric layer (302, 306) and by air gaps (314), each of the conductors (312) having air gaps (314) adjacent thereto separating the conductor (312) from the second dielectric layer (302, 306); and a third dielectric layer (316) overlying the conductors (312), wherein each of said conductors (312) has a cross-section wider at a top thereof than at a bottom thereof, in accordance with each of the air gaps (314) having a cross-section wider at a bottom thereof than at a top thereof and wherein the first dielectric layer (300) further includes a contacting stud (304) in contact with said conductor (312) (column 1, lines 41 – 52, column 2, lines 18 – 21, and column 4, line 25 – column 5, line 28).

Lee fails to teach wherein said first dielectric layer and said third dielectric layer each have a dielectric constant less than that of the second dielectric layer. However,

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Zhao (Fig.1A) teaches an interconnect structure including a first dielectric layer (12) having interconnects therein; a metal line (16, 30) formed on said first dielectric layer (12); a second dielectric layer (18) made of SiO<sub>2</sub> or low-k dielectric materials; and a third dielectric layer (26) made of SiO<sub>2</sub> or low-k dielectric materials such as polyimides, parylene and fluoropolymers, wherein said second dielectric layer (18) have air gaps (22) therein (Zhao, column 3, line 54 – column 8, line 60).

It would have been within the scope of one of ordinary skill in the art to combine the teachings of Lee and Zhao to enable the second and third dielectric layers of Lee to be made of the materials of Zhao because one of ordinary skill in the art at the time the invention was made would have been motivated to look to alternative suitable materials for the dielectric layers of Lee and art recognized suitability for an intended purpose has been recognized to be motivation to combine. MPEP 2144.07.

Although the combination of Lee and Zhao teach a third dielectric layer having a dielectric constant lower than that of the second dielectric layer and wherein the first dielectric layer further includes interconnects, the combined teachings of Lee and Zhao fail to teach wherein the first dielectric layer has a dielectric constant lower than that of the second dielectric layer. However, Chiang et al. (Figs.4 and 25) teach an interconnect structure formed on substrate (20) including multiple interlayer dielectric layers (22 in Fig.4, 322, 350, 391, 395) made of SiO<sub>2</sub>, fluoropolymer or polyimide (Chiang et al., column 6, lines 48 – 65). It would have been within the scope of one of ordinary skill in the art to combine the teachings of Lee and Zhao with Chiang et al. to enable the dielectric layer of the interconnect structure of Lee and Zhao to be made

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using the materials disclosed in Chiang et al. because one of ordinary skill in the art at the time the invention was made would have been motivated to look to alternative suitable materials for the first dielectric layer of Lee and Zhao and art recognized suitability for an intended purpose has been recognized to be motivation to combine. MPEP 2144.07.

### ***Response to Arguments***

3. Applicant's arguments with respect to claims 8, 10-12 has been considered but is moot in view of the new ground(s) of rejection.

### ***Conclusion***

4. Applicants are encouraged, where appropriate, to check Patent Application Information Retrieval (PAIR) (<http://portal.uspto.gov/external/portal/pair>) which provides applicants direct secure access to their own patent application status information, as well as to general patent information publicly available.

5. Any inquiry concerning this communication or earlier communications from the examiner should be directed to examiner Julio J. Maldonado whose telephone number is (571) 272-1864. The examiner can normally be reached on Monday through Friday.

6. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Matthew Smith, can be reached on (571) 272-1907. The fax number for this group is 571-273-8300. Updates can be found at <http://www.uspto.gov/web/info/2800.htm>.

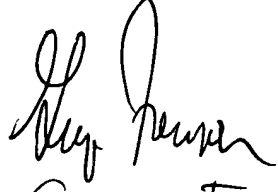
  
Julio J. Maldonado  
Patent Examiner

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Julio J. Maldonado  
June 5, 2006

  
George Fourson  
Primary Examiner